

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

2818
JRW

In re Patent Application of
Shunpei YAMAZAKI, et al
Serial No. 09/466,828
Filed: 12/20/99



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)
) Group Art Unit: 2818
) Examiner: Renee R. Berry

For: INSULATING FILM AND METHOD OF
PRODUCING SEMICONDUCTOR DEVICE

**REQUEST FOR ACKNOWLEDGMENT OF
INFORMATION DISCLOSURE STATEMENT**

Assistant Commissioner for Patents
P. O. Box 1450
Alexandria VA 22313-1450

Sir:

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with The United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P. O. Box 1450, Alexandria VA 22313-1450, on August 17, 2004.

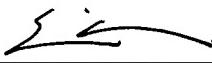
Renee R. Berry

Applicants acknowledge with appreciation the Notice of Allowability and Issue Fee Due form mailed July 29, 2004 acknowledging the filing of an Information Disclosure Statement on December 16, 2003.

The Notice of Allowability did not, however, include an initialed Form PTO-1449 acknowledging the Information Disclosure Statements filed May 10, 2002; April 2, 2003, and October 2, 2003. Therefore, it is respectfully requested that the Examiner evidence consideration of the references cited in the IDS of May 10, 2002; April 2, 2003 and October 2, 2003 by providing a copy of the initialed Form PTO-1449.

If a conference would beneficial in expediting the prosecution of the instant application, the Examiner is invited to telephone the undersigned to arrange such a conference.

Respectfully submitted,


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